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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

KENICHI HAMA, ET AL. : EXAMINER: ZHAO, X.

SERIAL NO: 10/516,732

FILED: DECEMBER 3, 2004 : GROUP ART UNIT: 4172

FOR: ROTARY TYPE CVD FILM FORMING APPARATUS FOR MASS PRODUCTION AND METHOD OF FORMING A CVD FILM ON THE INTERNAL SURFACE OF A PLASTIC CONTAINER

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Restriction Requirement of May 14, 2008, Applicants elect, without traverse, the invention of Group I, Claims 1-7 and 10.

RESPONSE TO RESTRICTION REQUIREMENT

Respectfully submitted,

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